

Attorney Docket No. 5649-874

## **PATENT**

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Hag-ju Cho Serial No.: 09/893,035 Filed: June 27, 2001

Group Art Unit: 2813 Examiner: Erik J. Kielin Confirmation No.: 3421

For METHODS OF MANUFACTURING INTEGRATED CIRCUIT DEVICES THAT INCLUDE A METAL OXIDE LAYER DISPOSED ON ANOTHER LAYER TO PROTECT THE OTHER LAYER FROM DIFFUSION OF

IMPURITIES AND INTEGRATED CIRCUIT DEVICES

MANUFACTURED USING SAME

Date: June 30, 2003

Mail Stop Non-Fee Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

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AMENDMENT

Applicant provides the present Amendment to address the issues raised in the Official Action mailed April 1, 2003 ("the Action"). The present amendment is provided in the Revised Amendment Format as published in the Official Gazette on February 25, 2003. The Revised Amendment Format waives certain requirements of 37 CFR 1.121.